Prototype Development of Self-Cleaning CSP Collectors

Boston University

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Project Objectives

- Maintain high optical efficiency of CSP systems by keeping solar collectors dust free
- Proof-of-concept of Electrodynamic Screens (EDS) for self-cleaning solar concentrators
- Prototype EDS-based self-cleaning solar collectors
 - Dust removal efficiency > 90%
 - Cleaning time period < 2 minutes</p>
 - Energy consumption < 0.1% of solar collector production</p>
 - Without requiring any water or manual labor
- Complete lab and field evaluations of prototype EDS integrated mirrors in collaboration with Sandia National Lab and Abengoa Solar Inc.





Examples of Dust Deposition

Dust storms severely decrease power output



- Nellis Air Force Base Solar Plant (Nevada)
- Currently, panels must be cleaned frequently with water.







Reflectance (CSP) and Transmission (CPV) Losses Reported from Different Plants

Location	Specimen	Exposure	Affected	Maximum
(latitude)	Туре	period	parameter	recorded loss
Albuquerque,	Silvered glass	5 weeks	Reflectance	25%
NM (35.11N)	mirror			
China Lake, CA	Heliostat	7 months	Reflectance	25%
(35N)	mirror			
Albuquerque,	Silvered glass	200 days	Reflectance	24.5%
NM (35.11N)	heliostat			
Albuquerque,	Mirror	8 weeks	Reflectance	14%
NM (35.11N)	samples			
Albuquerque,	Silvered glass	60 days	Reflectance	12.6%
NM (35.11N)	mirror			
Henderson, NV	Glass mirror	1 month	Reflectance	52%
(36N)				
	Aluminized	2 months	Reflectance	73%
	acrylic mirror			
San Antonio,	Glass mirror	2 months	Reflectance	20%
TX (29N)				
Dalton, GA	Mirror	1 month	Reflectance	3%
(34N)				
	Aluminized	1 month	Reflectance	8%
	acrylic mirror			
Riyadh, Saudi	CPV	12 day	Output power	30.6%
Arabia (24N)				
Madrid, Spain	CPV	5 months	Short-circuit	6.5%
(40N)			current	





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NM (35.11N)		Glass Wir	ror (5 wee	KS): 25%
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	Aluminized	2 months	Reflectance	73%
	acrylic mirror	CPV	(12 Davs)	: 30.6%
San Antonio,	Glass mirror	2 months	Reflectance	20%
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Transmission Loss Due to Dust Deposition







Fundamental Studies on Transparent Electrodynamic Screens (EDS)

- Dust charging mechanisms on the EDS surface
- Effects of size, shape, & chemical composition of dust particles, dielectric film on EDS surface, and pulsed voltage applied to electrodes
- Simulation of particle trajectories on EDS
- Theoretical analysis
- Experimental investigation





Fundamental Studies of EDS Operation

Particle adhesion and removal forces

- Forces of particle adhesion: $F_{adh} = F_{vdw} + F_{im} + F_{AB} + F_{CB} + F_{g}$
- Gravitational force: F_g = m_d g,
- Van der Waals force, $\tilde{F}_{vdw} = Ad/(12 z^2)$,
- Capillary force of attraction due to surface tension: $F_s = 2\pi d\gamma cos\theta + 2\pi d\gamma_{sl}$,
- Image force of adhesion: $F_{im} = q^2/(16 \pi \epsilon_o \epsilon_d t^2)$

Repulsive forces for dust removal during EDS operation:

- Coulomb Repulsive Force: F_c = q_dE
- Dielectrophoretic (DEP) Force $F_d = (P\nabla)E$
- The ratio of maximum repulsion force to the maximum force of attraction: $E(z)_{max}$, q_{max} , F_{adh} (max) = $E(z)_{max}$, q_{max} , $q_{max}^2/(16 \pi \varepsilon_o \varepsilon_d t^2)$]





Ratio of repulsion to adhesion forces



Methodology and Approach for EDS Use

Account for all forces on a single particle and compute its trajectory



Dust Removal Mechanism



Alternating coulomb force pushes dust particles upwards and laterally. Traveling wave causes deposited dust to slide off of the screen.



Optical Modeling Analysis (Collaboration with Sandia National Labs)



Electrodynamic screen integrated with solar-concentrator mirror

- (1) Fluoropolymer film
- (2) Thin layer of SiO₂
- (3) Parallel transparent electrodes
- (4) Borosilicate glass plate
- (5) Silver coating of back-surface reflectors





CPV Optics with **EDS**







Reflection efficiency by PU film (50 µm)



Reflection loss vs. transparency of electrodes



Materials being studied

- Substrates: Borosilicate glass, Heliostat mirrors, Polymer films
- Electrodes: Silver ink, PDOT:PSS, Silver nanowires, AZO
- Dielectric Film: Polyurethane, Urethane, ETFE, Tefzel
- Dust Samples: Sample dust from different deserts: Mojave Desert, Negev Desert, Gobi Desert, dust samples from Abu Dhabi, Saudi Arabia



Prototype EDS Development

- Surface treatment of substrates (Borosilicate glass or Second surface mirrors)
- Deposition of electrodes
 - Screen-printing
 - Ink-jet printing
 - Photolithography
- Application of transparent dielectric film to embed electrodes
- Production of power supplies, interconnection to EDS
- EDS testing for dust removal



Images of Screen-Printed EDS





First screen printing: two electrode phases Third phase printed on the dielectric stop-gap





Dielectric stop-gap printed over one phase Finished EDS fabricated with screenprinting



EDS on Rio-Glass Mirror



Left: Two fully functional EDS showing reflectivity of the mirror beneath the shield Right: Close-up of mirror image from the EDS-mirror system



EDS with transparent conducting ink





Low Frequency Low-Power Pulsed HV Supply

Power management



- CSP self-powers its own EDS
- Cleaning is automatically triggered by dust sensor on panel
- Operation for short periods only (not continuous)





Electrostatic Charging of Particles by EDS







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Surface mass concentration of desert dust on EDS surface





EDS Dust Removal Efficiency



Water Cleaning vs. EDS Cleaning







EDS Cost Analysis (Collaboration With Abengoa Solar Inc.)

Accomplishments

• Development of manufacturing cost module

 Collaboration with Abengoa Solar regarding input parameters

- Addition of power supply to cost module
- \odot Module analysis to isolate cost drivers
 - » Cost driver variation analysis
- Operational cost module progress

 Gathered data for general EDS operational expression

*EDS prototype module pertains to 15cm square borosilicate substrate





Modeling Overview



Purpose: To qualify major cost elements, and provide economic insights on tradeoffs associated with design and operational decisions





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Cost Analysis for Prototype Production



Sample output of fixed and variable cost breakdown for the manufacturing-cost model





EDS Payback Time Period Analysis Based on estimated EDS cost* per m²



EDS Lifetime (Years)

Data taken from manufacturing cost module estimates



Conclusions

Our Studies Show Feasibility of:

- Production and Evaluation of Self-cleaning CSP Optics
- Demonstration of Low-cost Self-cleaning Technology to Industry Partners, Investors (Abengoa Solar Inc.)
- Modeling and Field Testing at Sandia National Labs
- Partnership with Manufacturing Companies
- Cost-analysis of prototype production and scale-up
- Cost-effective application of EDS in CSP, CPV, and PV Optics





Video Demonstration



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